



Docket No.: ASMEX.367A

Customer No. 20,995

### INFORMATION DISCLOSURE STATEMENT

Applicant : Michael A. Todd  
App. No. : 10/074,534  
Filed : February 11, 2002  
For : PROCESS FOR DEPOSITION OF  
SEMICONDUCTOR FILMS  
Examiner : Shrinivas H. Rao  
Group Art Unit : 2814

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing references that are also enclosed.

This Information Disclosure Statement is being filed with an RCE or within three months of the filing date of this application and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 8/19/03

By: Joseph J. Mallon

Joseph J. Mallon  
Registration No. 39,287  
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FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMEX.367A	APPLICATION NO. 10/074,534
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (USE SEVERAL SHEETS IF NECESSARY)		APPLICANT Michael A. Todd	
		FILING DATE February 11, 2002	GROUP 2814

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
1.	5,214,002	05/25/93	Hayashi et al.			
2.	5,356,821	10/18/94	Naruse et al.			
3.	5,471,330	11/28/95	Sarma			
4.	6,103,600	08/15/00	Ueda et al.			

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
5.	11317530	16-11-99	Japan (abstract)			X	
6.	EP 0368651 A2	16-05-90					
7.	EP 0486047 A2	20-05-92					
8.	EP 0747974 A2	11-12-96					
9.	EP 1065728 A2	03-01-01					
10.	GB 2332564 A	23-06-99	United Kingdom				

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)
11.	Olivares, J. et al.; "Solid-phase crystallization of amorphous SiGe films deposited by LPCVD on SiO <sub>2</sub> and glass," Thin Solid Films 337 (1999) pp. 51-54.

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EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	